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Monolithic crystalline silicon solar cells with SiN_x layers doped with Tb³⁺ and Yb³⁺ rare-earth ions[☆]

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In this study, we propose the fabrication of monolithic crystalline silicon solar cells with Tb³⁺ and Yb³⁺-doped silicon nitride (SiN_x) layers by low-cost screen-printing methods. The performances of c-Si solar cells can be enhanced by rare-earth ions doped SiN_x layers via the mechanism of spectrum conversion. These SiN_x doped and codoped thin films were deposited by reactive magnetron co-sputtering and integrated as the antireflection coating layers in c-Si solar cells. The characterizations of SiN_x, SiN_x:Tb³⁺ and SiN_x:Tb³⁺-Yb³⁺ thin films were conducted by means of photoluminescence, Rutherford backscattering spectroscopy, Ellipsometry spectroscopy and Fourier transform infrared measurements. Their composition and refractive index was optimized to obtain good anti-reflection coating layer for c-Si solar cells. Transmission electron microscopy performs the uniform coatings on the textured emitter of c-Si solar cells. After the metallization process, we demonstrate monolithic c-Si solar cells with spectrum conversion layers, which lead to a relative increase by 1.34% in the conversion efficiency.

1. Introduction

Energy crisis and global warming are two important issues in twenty-first century. Solar energy is one of the solutions to solve these problems. Now, many materials are proposed for photovoltaic technologies such as Si, GaAs, CdTe and CIGS.¹ In industry, crystalline silicon (c-Si) solar cell is still the mainstream among the various technologies of solar cells. The conversion efficiency of c-Si solar cells can be improved by reducing optical loss, carrier recombination loss and electrical loss. So far, the best experimental c-Si solar cells fabricated in the laboratories have achieved conversion efficiency of 25%.^{2,3} Beside these above mentioned loss mechanisms, the main energy loss of c-Si for converting solar energy to electricity is the mismatch of the solar spectrum and the band gap energy of Si. The sub-bandgap photons ($E < 1.1$ eV) cannot be absorbed by Si solar cells. The excess energy of high energetic

photons ($E > 1.1$ eV) is lost via non-radiative relaxation in the form of heat. The fundamental spectral loss that limits the theoretical maximum efficiency of single junction Si device is around 31%, which is known as the Shockley-Queisser efficiency limit.⁴ To break this limitation, several methods were proposed, such as tandem solar cells, intermediate-band cells, hot carrier cells and spectrum conversion. All those methods are clustered in the third generation photovoltaic cells.⁵

To increase conversion efficiency of a single junction solar cell, such as c-Si solar cells, spectrum conversion is a good method to modify solar spectrum by means of down-conversion (i.e. quantum cutting), down-shifting or up-conversion. Down-conversion is the process of splitting one high energy photon into more than one lower energy photons which can be absorbed by the cell. Down-shifting is the process of absorbing one high energy photon and releasing one lower energy photons for better absorption. Up-conversion is the process to combine two low energy photons into one absorbable photon by the Si solar cell. Traditional single junction c-Si solar cells are fabricated by thermal diffusion and screen printing processes for a low-cost approach. External quantum efficiency (EQE) of c-Si solar cells is still poor at short-wavelength range (from 300 to 500 nm) because of the recombination at the surface layer with heavily phosphorus-doped emitter

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and increased reflectance and absorption from antireflection coating (ARC). However, luminescent down-conversion and down-shifting materials have been proposed for improving the poor spectral response of c-Si solar cells to short wavelength light. These materials can also decrease slightly the operational temperature due to electron-hole pair thermalization losses in the cells.^{6–9}

Rare-earth ions (lanthanide ions) doped materials can absorb and emit light via the energy levels of the active ions. Those rare-earth ions may be praseodymium (Pr^{3+}), erbium (Er^{3+}), europium (Eu^{3+}), samarium (Sm^{3+}), cerium (Ce^{3+}) and terbium (Tb^{3+}) in different host materials. These luminescent materials have been used in the lighting, display panel, photocatalytic and photovoltaic technologies.^{10–17} For a better integration with c-Si solar cell process, rare-earth ions were inserted in a specific oxide or nitride environment. In the material, those rare-earth ions are mostly stable as divalent or trivalent cations and can efficiently convert UV radiation into visible light as down-shifting layers.¹⁸ Besides, down-conversion layers using rare earth ion pairs can provide the energy transfer from one rare-earth ion to another one such as in the $\text{Tb}^{3+}-\text{Yb}^{3+}$, $\text{Pr}^{3+}-\text{Yb}^{3+}$ or $\text{Nd}^{3+}-\text{Yb}^{3+}$ codoped systems.^{19–23} Thus the down-shifting and down-conversion layers can theoretically be used to improve the performance of c-Si solar cell by reducing the thermalization process.

As we know, silicon nitride (SiN_x) thin film has been used as ARC layer at the front side of p-type c-Si solar cells in industry.²⁴ In this report, Tb^{3+} -doped and $\text{Tb}^{3+}-\text{Yb}^{3+}$ -codoped SiN_x thin films were deposited by reactive radio frequency magnetron co-sputtering using three different metallic targets: silicon, terbium, and ytterbium, under a mixture of argon and nitrogen plasma. In addition, $\text{SiN}_x:\text{Tb}^{3+}$ thin film was integrated into c-Si solar cell as the down-shifting layer. $\text{SiN}_x:\text{Tb}^{3+}-\text{Yb}^{3+}$ thin film was integrated into c-Si solar cell as the down-conversion layer. Finally, a monolithic c-Si solar cell with spectrum conversion layers was demonstrated, and the enhanced performance of c-Si solar cells with these layers was investigated.

2. Experimental

In this work, SiN_x , $\text{SiN}_x:\text{Tb}^{3+}$ and $\text{SiN}_x:\text{Tb}^{3+}-\text{Yb}^{3+}$ layers were deposited by reactive magnetron co-sputtering in nitrogen-rich plasma. For the deposition parameters, the power density applied on the Si target was fixed at 4.5 W/cm^2 , and the gas fluxes were $1.35 \times 10^{-2} \text{ Pa} \cdot \text{m}^3/\text{s}$ for argon and $3.38 \times 10^{-3} \text{ Pa} \cdot \text{m}^3/\text{s}$ for nitrogen. The deposition operated at plasma pressure 0.40 Pa, and the substrate temperature was fixed at $200 \text{ }^\circ\text{C}$. The doping of rare-earth ions was controlled by the power densities separately applied on the terbium and ytterbium metal targets. The deposition time was adjusted to obtain 80 nm-thick films which requires an ARC layer with a refractive index around 2.2 (at 1.95 eV). The optimized photoluminescence emission in the visible range for the Tb^{3+} ions or in the infrared one for the Yb^{3+} ions has been achieved after an annealing process at $850 \text{ }^\circ\text{C}$. The composition of the produced layers was determined by Rutherford backscattering spectroscopy (RBS) while refractive index and thickness were deduced from ellipsometry spectroscopy experiments. Fourier transform infrared measurement (FTIR) was employed to investigate the Si–N bond in the layers.

Fig. 1 shows the process flow of monolithic c-Si solar cells with two different spectrum conversion layers. First, 200- μm p-type Si wafer was cleaned by KOH solution to remove the saw damage as well as for surface texturing. Second, Si doped phosphorus was conducted by thermal diffusion at $850 \text{ }^\circ\text{C}$ for 30 min. Then, isolation etching process was provided to remove the edge and backside n-type Si. Then, samples were cut into the size of $3.5 \text{ cm} \times 3.5 \text{ cm}$. Prior to spectrum conversion layers deposition, the samples were

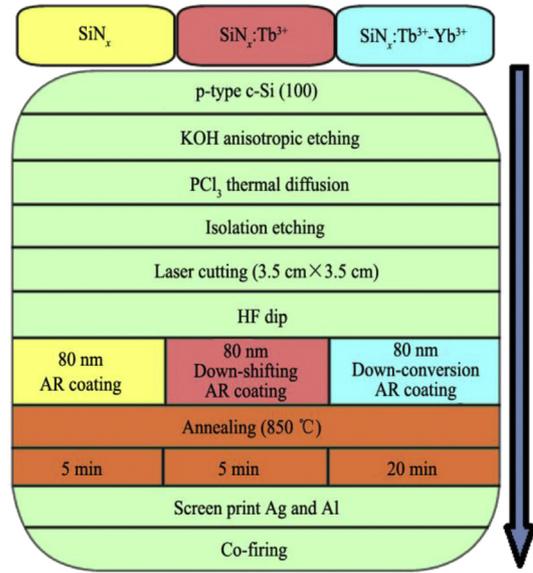


Fig. 1. Process flow of c-Si solar cells with spectrum conversion layers.

cleaned by HF solution to remove native oxide layer on the surface. Three different thin films were then deposited by sputtering¹⁶ and followed by a thermal annealing process to recover the non-radiative paths in these layers. Finally, the metallization of c-Si solar cells, consisting in a screen-printing of metals and a co-firing process, was conducted. After these processes, a monolithic c-Si solar cell with spectrum conversion layers was obtained as is shown by the schematic diagram in Fig. 2. This report consists of three parts: the characterization of spectrum conversion layers, optical properties of spectrum conversion layers on c-Si solar cells, and the performances of solar cells with these layers.

3. Results and discussion

3.1. Characterizations of SiN_x , $\text{SiN}_x:\text{Tb}^{3+}$ and $\text{SiN}_x:\text{Tb}^{3+}-\text{Yb}^{3+}$ layers

The results of the RBS measurements for those three samples are shown in Table 1. The composition of SiN_x in the three layers is close to the stoichiometric composition (Si_3N_4) even when rare-earth ions are added. The doping concentrations of Tb^{3+} and Yb^{3+} ions in the matrix achieved by RBS analysis are also exhibited in Table 1.

Fig. 3 shows the refractive index at 1.95 eV for the three layers. The blue line represents the refractive index of the stoichiometric silicon nitride, Si_3N_4 . We can find that the refractive index increases

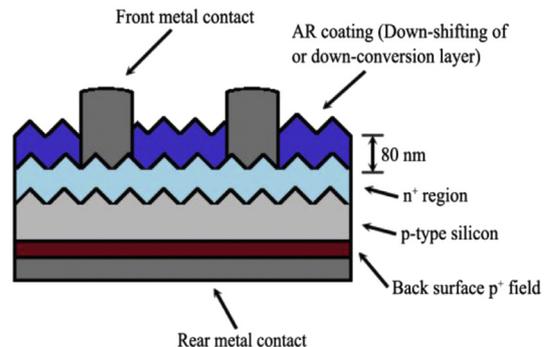
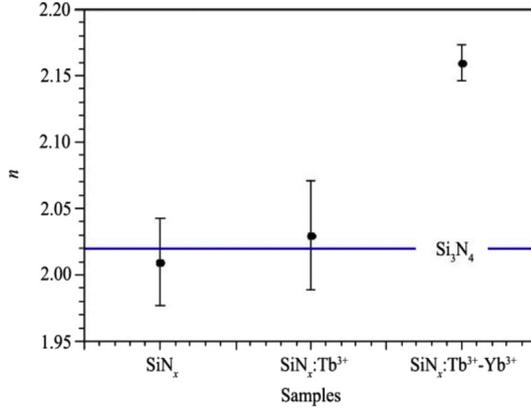


Fig. 2. Schematic diagram of c-Si solar cells with spectrum conversion layers.

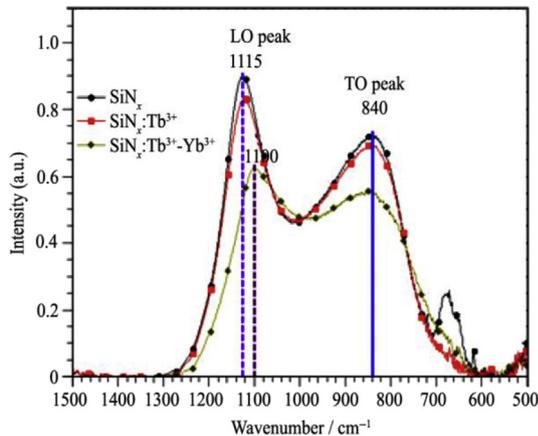
Table 1The composition analysis of SiN_x and doped SiN_x layers by RBS (at%).

Samples	Si	N	Tb	Yb
SiN _x	43	57	—	—
SiN _x :Tb ³⁺	42	56	1.5	—
SiN _x :Tb ³⁺ -Yb ³⁺	39.5	52.7	5.8	2

**Fig. 3.** Refractive index of three layers at 1.95 eV deduced from Ellipsometry analysis.

when the matrix is doped with one or two types of rare-earth ions. The doping of 1.5 at% terbium in the SiN_x matrix raises refractive index 0.02. The doping of 7.8 at% rare-earth ions leads to an increase of the refractive index 0.14. These are still in the acceptable range (from 2.0 to 2.2) for the application in c-Si solar cells.

The FTIR analysis was conducted on the three samples and the results are shown in Fig. 4. The two peaks present the longitudinal optical (LO) and the transversal optical (TO) modes of the asymmetric Si–N bond. The position of the TO peak does not vary between the samples. The LO peak's position shifts to the low wavenumbers when rare-earth ions are inserted in the SiN_x matrix. This shift may be attributed to a decrease in the silicon content compared with the nitrogen one, or to an increasing stress in the matrix due to the increasing insertion of rare-earth ions in the matrix.²⁵ In addition, the range of wavenumber between those two peaks (1100–900 cm⁻¹) may be related to the lattice vibration that is a signature of the matrix disorder. Fig. 4 shows that the intensity difference between this part of the spectrum and the two peaks became smaller when one then two types of rare-earth ions are

**Fig. 4.** FTIR spectra for the three different layers: the two peaks present LO and TO modes of the asymmetric Si–N bond.

incorporated in the matrix. Thus, the shift of the LO peak towards the low wavenumbers should be attributed to the increase of disorder due to the insertion of rare-earth ions.

3.2. Microstructures and optical properties of these layers on textured emitter

After the fabrication of c-Si solar cells, these layers were integrated in monolithic c-Si solar cells. Fig. 5 shows the images of cross-section transmission electron microscopy. The microstructure of SiN_x doped with Tb³⁺-Yb³⁺ thin films can be observed on the textured Si surface by TEM observations. The layers were uniformly coated on the textured emitter of c-Si solar cells with the thickness around 70 nm.

The optical properties of these layers can be characterized by photoluminescence, and reflectance measurements. In Fig. 6, the emission of SiN_x layer is very weak compared with the doped layers. However, it emits from and below 488 nm allowing the energy transfer from the matrix to the terbium ions. Such sensitization effect of rare-earth ions allow to overcome their low absorption cross section as already demonstrated in such a nitride based matrix. In addition, it has been determined that this transfer most likely occurs toward the high energy levels of the terbium ions before undertaking relaxation to the ⁵D₄ energy level as shown by An et al.^{16,18} Tb³⁺ ions in the SiN_x matrix emit from 500 to 630 nm as displayed in Fig. 6 which exhibits the four characteristic peaks of the terbium at 629, 594, 550 and 493 nm that correspond to the ⁵D₄ to ⁷F₃, ⁷F₄, ⁷F₅, and ⁷F₆ energy transfers. The UV light can thus be absorbed by matrix and then transferred to the Tb³⁺ ions that will then transfer the converted light to the Si. Therefore, SiN_x:Tb³⁺ can be a down-shifting layer for c-Si solar cell. For the SiN_x:Tb³⁺-Yb³⁺ thin film, this layer only presents the characteristic peak of the Yb³⁺ at 990 nm which originates from the ²F_{5/2} to ²F_{7/2} energy transfer. The spectra show a mechanism of spectral down-conversion, energy transfer from one rare-earth ion to two other rare-earth ions. Thus, SiN_x codoped with Tb³⁺-Yb³⁺ ions can be a down-conversion layer for c-Si solar cell.

The reflectivity of these layers on textured emitter is important for c-Si solar cells because these layers also play the role of an ARC layer. Fig. 7 shows the reflectance as a function of the wavelength. The minimum of reflectance is between 400 and 500 nm. The reflectance increases at shorter wavelength, and a bump rising of reflectance at around 1050 nm is observed. To overall justify the ARC performance of our layers for solar cells, we can calculate the weighed average reflectance (WAR) at AM1.5G in the range of 300 and 1200 nm. The WAR value of these layers on the textured Si is around 6%, which shows the good light harvesting as ARC layers for c-Si solar cells.^{26,27}

3.3. Performances of c-Si solar cells with these three layers

In previous section, the optical properties of rare-earth ion doped SiN_x layers on textured emitters can be spectrum conversion and ARC layers for c-Si solar cells. We move forward to realize the performance of monolithic c-Si solar cells with these layers. After the process of metallization, external quantum efficiency (EQE) measurement was employed to get the short-circuit current density (*J*_{sc}), and pseudo *I*–*V* curve without the effect of series resistance could be obtained by Sinton's Suns *V*_{oc} measurement.^{28,29}

Fig. 8 shows the *I*–*V* curves of three cells, and inset is the zoom of curves. The photovoltaic performances of these cells are summarized in Table 2. To compare with the c-Si solar cell without rare-earth ion doping, the performances of c-Si solar cell with SiN_x doped with Tb³⁺ or codoped with Tb³⁺-Yb³⁺ have enhancement in short-circuit current density and open-circuit voltage (*V*_{oc}). The conversion efficiency is from 17.13% to 17.31% for the down-shifting

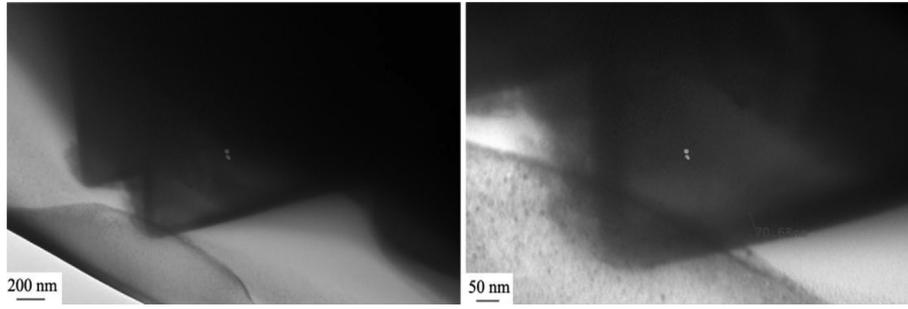


Fig. 5. TEM images of SiN_x doped with Tb^{3+} - Yb^{3+} on textured emitters.

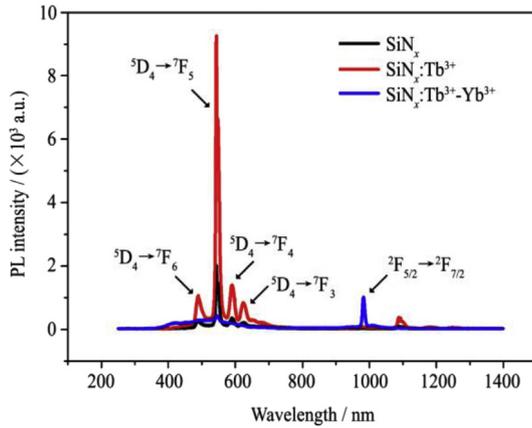


Fig. 6. PL measurements equipped with a 325 nm laser for the three layers on textured emitters of solar cells.

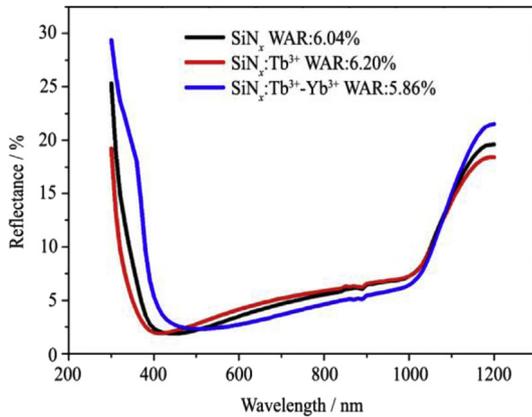


Fig. 7. Reflectance of three layers deposited on textured emitters.

layer (SiN_x doped with Tb^{3+}). The conversion efficiency is from 17.13% to 17.36% for the down-conversion layer (SiN_x codoped with Tb^{3+} - Yb^{3+}).

The performance enhancement of Si solar cells both comes from the anti-reflection and spectrum conversion effects of these films. From the WAR values of three different layers as 6.04%, 6.20% and 5.86%, the corresponding weighed average transmission of 93.96%, 93.80% and 94.14% can be obtained. To normalize the effect of anti-reflection coating, the ratios of conversion efficiency to transmission can be calculated as 18.23%, 18.45% and 18.44%, respectively. The SiN_x films doped with Tb^{3+} or codoped with Tb^{3+} - Yb^{3+} can enhance the performance of c-Si solar cells due to the effect of spectrum conversion.

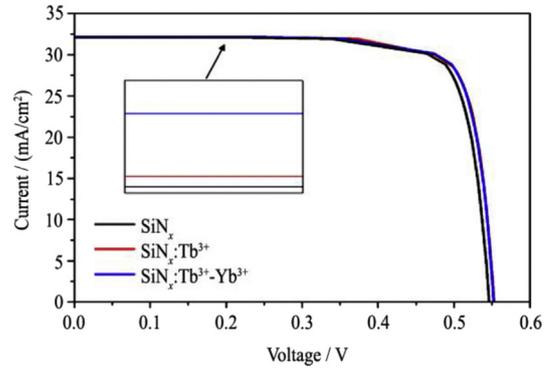


Fig. 8. Pseudo I - V curves for three c-Si solar cells with SiN_x , $\text{SiN}_x:\text{Tb}^{3+}$ and $\text{SiN}_x:\text{Tb}^{3+}$ - Yb^{3+} layers, respectively.

Table 2

Photovoltaic performances of c-Si solar cells with SiN_x , $\text{SiN}_x:\text{Tb}^{3+}$ and $\text{SiN}_x:\text{Tb}^{3+}$ - Yb^{3+} layers.

Samples	J_{sc} (mA/cm ²)	V_{oc} (V)	Pseudo FF (%)	Pseudo Efficiency (%)	Efficiency to normalized transmission (%)
SiN_x	32.091	0.546	0.804	17.13	18.23
$\text{SiN}_x:\text{Tb}^{3+}$	32.098	0.552	0.803	17.31	18.45
$\text{SiN}_x:\text{Tb}^{3+}$ - Yb^{3+}	32.165	0.552	0.806	17.36	18.44

4. Conclusions

A monolithic c-Si solar cell with spectrum conversion layers was demonstrated with Tb^{3+} doped SiN_x and Tb^{3+} - Yb^{3+} codoped SiN_x thin films. These thin films can not only play the role as anti-reflection coating, but also improve the performances of c-Si solar cells due to the spectrum conversion effects (down-shifting and down-conversion). From the characterizations of these films, their composition and refractive index are close to stoichiometric Si_3N_4 . The layers with the thickness of 70 nm are uniformly coated on the textured emitter of c-Si solar cells. For the down-shifting layer, the UV light can be absorbed by matrix and then transfer to the Tb^{3+} ions. For down-conversion effect layer, energy transfers from one rare-earth ion to two other rare-earth ions from the PL measurements.

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